WHAT IS CLAIMED IS:

1. An apparatus for disinfecting and cleaning a headset, comprising:

a chamber having an inner volume sufficient to accommodate the headset;

a power supply coupled to the chamber;

an ultraviolet (UV) light source coupled to the power supply, wherein the UV light source is disposed to shine UV light onto a surface of the headset configured for placement against a face of a user;

an air jet port coupled to a wall of the chamber; and

a closed-circuit air tube connected to the air jet port, the closed-circuit tube including vents disposed to blow pressurized air around the headset to remove detritus from surfaces of the headset and dry the headset.

2. The apparatus of claim 1, wherein the UV light source comprises a ring-shaped body and includes a plurality of UV light emitting diodes (LEDs) positioned around a perimeter of the ring-shaped body.

3. The apparatus of claim 2, wherein the perimeter of ring-shaped body is sized to fit within an inner circumference of the headset defined by an open area between the surface of the headset configured for placement against the face of the user and straps or arms of the headset configured to secure the headset around a head of the user.

4. The apparatus of claim 3, wherein the UV LEDs are positioned on an outer surface of the ring-shaped body facing the inner circumference of the headset when the headset is placed into the chamber.

5. The apparatus of claim 1, wherein the vents of the closed-circuit air tube are positioned to blow directly at a portion of the surface of the headset configured for placement against the face of the user.

6. A system for disinfecting and cleaning headsets, comprising:

a nanotech coating applied to a surface of a headset configured for placement against a face of a user;

a chamber having an inner volume sufficient to accommodate the headset; a power supply coupled to the chamber; and

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an ultraviolet (UV) light source coupled to the power supply, wherein the UV light source is disposed to shine UV light onto the surface of the headset configured for placement against a face of a user, and wherein the UV light source comprises a ring-shaped body and includes a plurality of UV light emitting diodes (LEDs) positioned around a perimeter of the ring-shaped body.

7. The system of claim 6, further comprising:

an air jet port coupled to a wall of the chamber; and

a closed-circuit air tube connected to the air jet port, the closed-circuit tube including vents disposed to blow pressurized air around the headset to remove detritus from the surface of the headset configured for placement against a face of a user and dry the headset.

8. The system of claim 6, wherein the UV light source emits a UV-C type light.

9. The system of claim 6, wherein the UV LEDs are positioned within two inches of the surface of the headset configured for placement against a face of a user when the headset is placed into the chamber.

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